

Notice of References Cited

Application/Control No.

10/017,701

Applicant(s)/Patent Under
Reexamination
CHEN ET AL.

Examiner

Cindy Nguyen

Art Unit

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U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-5,918,232	06-1999	Pouschine et al.	707/103R
	B	US-2002/0198891	12-2002	Li et al.	707/102
	C	US-6,075,530	06-2000	Lucas et al.	345/804
	D	US-2002/0013782	01-2002	Ostroff et al.	707/10
*	E	US-6,308,177	10-2001	Israni et al.	707/100
*	F	US-6,167,405	12-2000	Rosensteel et al.	707/102
*	G	US-6,636,870	10-2003	Roccaforte, Raymond	707/101
*	H	US-2002/0029207	03-2002	Bakalash et al.	707/1
*	I	US-6,202,063	03-2001	Benedikt et al.	707/3
	J	US-			
	K	US-			
	L	US-			
	M	US-			

FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
	P					
	Q					
	R					
	S					
	T					

NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	
	V	
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	X	

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